

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Härle et al.                      Art Unit : 2892  
Serial No. : 10/813,530                              Examiner : Chuong A. Luu  
Filed : March 29, 2004                              Conf. No. : 5329  
Title : METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED  
ON A NITRIDE COMPOUND SEMICONDUCTOR

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Please consider the references listed on the enclosed PTO-1449 form. Foreign patent documents and non-patent literature are enclosed.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. The fee of \$180 in payment for the late submission fee of §1.17(p) is being paid concurrently herewith on the Electronic Filing System (EFS) by way of Deposit Account authorization.

Please apply any other charges or credits to Deposit Account No. 06-1050, referencing Attorney Docket No. 12406-0140001.

Respectfully submitted,

Date: September 11, 2008

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